

Docket No.: 87324.1760

PATENT

## LIST OF ART CITED BY APPLICANT

(PTO-1449)

ATTY. DOCKET NO.

87324.1760

SERIAL NO.

10/619,143

APPLICANT

Deepak SAHA

FILING DATE

July 15, 2003

GROUP

1725

## U.S. PATENT DOCUMENTS

	EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	✓	6,200,396B1	3/13/01	Laslaz et al.	148	437	12/7/1999
B	✓	5,355,930	10/18/94	Donahue et al.	164	34	9/9/1993
C							
D							
E							
F							
G							
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I							
J							
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## FOREIGN PATENT DOCUMENTS

	EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
U	✓	56146845	11/14/81	Japan			Abst.
V	✓	WO 00/43152	7/27/00	PCT			
W	✓	1089159	4/30/84	Soviet Union			
X							
Y							
Z							
AA							
BB							
CC							
DD							
EE							
FF							
GG							

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

HH	✓	Tatsuya Ohmi, et al., "Effect of Casting Condition on Refinement of Primary Crystals in Hypereutectic Al-Si Alloy Ingots Produced by Duplex Casting Process", J. Japan Inst. Metals, Vol. 56, No. 9, 1992, pp. 1064-1071.
II	✓	Tatsuya Ohmi, et al., "Control of Primary Silicon Crystal Size of Semi-Solid Hypereutectic Al-Si Alloy by Slurry-Melt Mixing Process", J. Japan Inst. Metals, Vol. 58, No. 11, 1994, pp. 1311-1317.
JJ		
KK		
LL		

EXAMINER

Lan Tran

DATE CONSIDERED

6/27/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

